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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Confirmation No. 9577

Tetsuji TOGAWA et al.

Docket No. 2001-0998A

Serial No. 09/903,581

Group Art Unit 3723

Filed July 13, 2001

Examiner Eileen P. Morgan

POLISHING APPARATUS

AMENDMENT

RECEIVED

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TECHNOLOGY CENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of January 14, 2004, kindly amend the above-referenced U.S. patent application as follows: